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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Dwight Zuck and David Zuck
Assignee: Quantum Global Technologies, LLC
Title: System for Removing Contaminants from
Semiconductor Process Equipment
Serial No.: 10/622,393 Filed: 07/18/2003
Examiner: Stinson, Frankie L. Group Art Unit: 1746
Atty. Doc. No.: Z-001-2C

Mail Stop _____
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT IN RESPONSE TO FIRST OFFICE ACTION

Sir:

In response to the Office Action dated June 17, 2004, please
amend the above-identified patent application as follows:

08/31/2004 HVUONG1 00000005 10622393

01 FC:2202 54.00 OP
02 FC:2201 43.00 OP